



Patent
52478.9100

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Toshiya Fukuhisa *et al.*

Application No.: 09/515,285

Filed: February 29, 2000

For: SEMICONDUCTOR LASER AND
MANUFACTURING METHOD FOR
THE SAME

Examiner: Tuan M. Nguyen

Art Group: 2828

12k Pre
And
11-3-03
A. Weck

RESPONSE TO FINAL ACTION

Mail Stop RCE
Assistant Commissioner for Patents
Washington, DC 20231-9998

Sir:

In response to the outstanding Final Action, mailed August 5, 2003, Applicants submit the following claims and arguments. Please amend the above-identified application for patent as follows. Amendments in this Response are presented in the following pages in compliance with 37 CFR 1.121.

Claims 1, 11, 12, 25, 35, and 36 have been amended. Claims 39-43 have been cancelled.

Claims 1-38 remain pending in the application.

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